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in the following listed application(s) or patent(s) for which the issue fee has been paid.

<u>Patent No.</u>	<u>Serial No.</u>	<u>Patent Date</u>	<u>US 371 Filing Date</u>	<u>Confirmation No.</u>	<u>Attorney Docket No.</u>
7,569,988 B2	10/579,691	8/4/09	5/18/06	9637	0553-0500

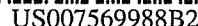
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(10) **Patent No.:** **US 7,569,988 B2**
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- (57)
- ABSTRACT**

- An object of the invention is to provide a highly reliable light emitting element with low drive voltage and longer life than a conventional light emitting element, and a display device using the light emitting element. A light emitting element according to the invention comprises a plurality of layers which is interposed between a pair of electrodes, in which at least one of the plurality of layers is formed of a layer containing a light emitting material, and the layer containing a light emitting material is interposed between a layer containing an oxide semiconductor and/or metal oxide and a material having a higher hole transporting property than an electron transporting property, and a layer containing an oxide semiconductor and/or metal oxide, a material having a higher electron transporting property than a hole transporting property and a material which can donate electrons to the material having a higher electron transporting property than a hole transporting property.

- 28 Claims, 13 Drawing Sheets**

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- (51) Int. Cl.
H01J 1/62 (2006.01)

- (52) **U.S. Cl.** **313/506; 313/504; 313/512**

- (58) **Field of Classification Search** 313/503,
313/504, 506, 512

See application file for complete search history.

